



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named

Inventor : Roger L. Hipwell, Jr.

Appln. No. : 09/707,698

Filed : November 7, 2000

Title : LATERALLY SUPPORTED HANDLE
WAFER FOR THROUGH-WAFER
REACTIVE-ION ETCH
MICROMACHINING

Docket No. : I69.12-0467

Group Art Unit: 1763

Examiner: Olsen, Allan
W.

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AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SENT VIA EXPRESS MAIL

Express Mail No.: EV 302260735 US

Sir:

This is in response to the Office Action mailed on July 7, 2003 (Paper No. 4). Please amend the above-identified application as follows: